Phase Diagram of Electrostatically Doped SrTiO₃

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Electric double layer transistor configurations have been employed to electrostatically dope single crystals of insulating $SrTiO_3$. Here we report on the results of such doping over broad ranges of temperature and carrier concentration employing an ionic liquid as the gate dielectric. The surprising results are, with increasing carrier concentration, an apparent carrier-density dependent conductor-insulator transition, a regime of the anomalous Hall effect, suggesting magnetic ordering, and finally the appearance of superconductivity. The possible appearance of magnetic order near the boundary between the insulating and superconducting regimes is reminiscent of effects associated with quantum critical behavior in some complex compounds.

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Strontium titanate (STO) is a band insulator which has been rendered conducting and superconducting at sufficiently low temperatures by introducing oxygen defects, by doping with Nb, Zr, La, or Ta [1-7], through charge transfer processes resulting from the deposition of several layers of $LaAlO_3$ [8], by electrostatic charging using a conventional field effect transistor (FET) configuration [9], and by charging using an electric double layer transistor (EDLT) configuration employing a polymer electrolyte [10]. In this Letter we report the results of an electrostatic charging experiment on SrTiO₃ using an ionic liquid (IL) in an EDLT configuration, which has revealed unexpected features in the phase diagram as a function of temperature and carrier concentration, resembling those in the phase diagrams of unconventional superconductors, or systems exhibiting quantum critical behavior [11,12].

EDLTs are configurations which perform in a manner similar to conventional FETs. They contain a gate electrode, a semiconductor or insulator into which charge can be accumulated or depleted, source and drain electrodes, and for purposes of characterization, electrodes for measuring longitudinal and transverse voltages relative to the current direction. In this instance the gate dielectric is an IL, although polymer electrolytes have also been employed. ILs are molten salts consisting of large ions such that their Coulomb interaction is sufficiently small to make them room temperature liquids. They have previously been used to modify the conductivity of ZnO, and ZrNCl, revealing a metal-insulator transition in ZnO, and superconductivity in ZrNCl [13–16]. Upon applying a gate voltage, ions move to the surface of the semiconductor or insulator, forming an electric double layer (EDL) such that with the charge induced in the channel, acts as a capacitor of nanoscale thickness. A schematic of the operation of an EDLT is shown in Fig. 1. With ILs, charge transfers of order 10^{14} cm⁻² or higher are possible, opening up the possibility of significant modification of the electronic properties of materials [17]. The advantage of using ILs over almost all solid gate dielectrics is a greatly enhanced charge transfer for the same gate voltage.

Pristine STO (100) single-crystals were obtained from Princeton Scientific Corp. Their surfaces were treated with buffered hydrofluoric acid for 30 seconds and annealed at 780 °C for 6 hours to yield an atomically flat surface terminated by TiO₂ [18]. Electrodes in a typical Hall bar geometry along with a four-probe configuration for measuring longitudinal resistance were prepatterned by means of photolithography as shown in Fig. 1. Prior to the deposition of Ti/Au electrodes (each layer, 70 nm in thickness), the STO was ion milled to a depth of 70 nm to create a layer of oxygen-deficient metallic SrTiO_{3- δ}. The depth of milling of the STO is shown in Fig. 1. Milling was carried



FIG. 1 (color online). Schematic diagrams of the sample and the operation of an EDLT: (Left) Upon application of a positive gate bias, anions are attracted to the gate electrode and cations are repelled, this creates an EDL at the sample surface. (Right) Schematics of top and side views of the sample design. A Pyrex glass cylinder was glued onto the STO wafer using a common epoxy to serve as an IL container. Oxygen-deficient SrTiO_{3-δ} was created below and around the Ti/Au electrodes, but not across the channel.

out to insure ohmic contact between the Ti/Au electrodes and the surface layer of STO that would be electrostatically gated into a conductive state [19]. Next a 100 nm thick layer of SiO₂ was deposited through a photo-patterned mask onto the STO to define a conducting channel 140 μ m \times 70 μ m in area. The IL used here was N, *N*-diethyl-*N*-(2-methoxyethyl)-*N*-methylammonium bis (trifluoromethyl sulphonyl)-imide (DEME-TFSI). This particular IL has produced very high charge accumulations on the surface of semiconductors such as ZnO with induced sheet carrier densities (n_s) of up to 8×10^{14} cm⁻² being reported [16]. Moreover the ions of this IL are mobile down to 200 K. The ability to apply a gate voltage, V_g , at this relatively low temperature enables us to raise voltage V_g as high as 5 V without significant and irreversible chemical degradation that would occur at higher temperatures.

Four-probe measurements were employed to determine the resistance of samples. A Quantum Design Physical Property Measurement System (PPMS) equipped with a ³He refrigerator insert enabled us to vary the temperature between 300 and 0.35 K and the magnetic field between 0 T and 9 T. As the IL, DEME-TFSI, undergoes a rubberlike phase transition below 240 K and becomes a glasslike solid below 200 K, where the ionic mobility falls to zero [16]. V_g was always changed at 230 K. and ranged from 0 V to 3 V. It was applied using a Keithley electrometer (Model 6517A), and was held constant throughout subsequent cooling and measurement.

The temperature dependencies of the sheet resistances R_s , of an STO crystal at various values of n_s are plotted in Fig. 2. Undoped STO exhibited no measurable conductivity, and only with V_g in excess of 1.8 V was it possible to measure nonzero conductivity. Within a given cycle of cooling and warming at a fixed value of V_g , there was no more than a 5 to 10% shift in resistance when the crystal was brought back to 230 K. In a set of independent measurements using this IL, the value of the capacitance in a parallel plate configuration exhibited a small time dependence, owing to the complex dynamics of the IL in its glassy state [20,21]. Areal carrier density, n_s , rather than V_g , is the intrinsic parameter. Values of n_s were obtained from Hall effect data at 180 K, which were measured in magnetic fields B, of up to 5 T, and n_s ranged from 1 \times 10^{10} cm⁻² to 8×10^{14} cm⁻². The highest value of n_s ever induced was 1.5×10^{15} cm⁻². The areal carrier concentration, $n_s(V_g)$, was not linear in V_g , which is probably a consequence of the voltage dependence of the IL's dielectric properties.

In most plots of $R_s(T)$, we observed a sharp resistance rise at a temperature which depended upon n_s which was not instrumental. This could be due to the reduction of carriers thermally excited from states within the band gap, when decreasing the temperature. Such an effect is believed to be responsible for the temperature dependence



FIG. 2 (color online). Sheet resistance (R_s) vs temperature (T) on cooling, at various sheet carrier densities (n_s) (in units of 10^{13} cm⁻², obtained from the Hall effect at 180 K). When $n_s \ge 3.3 \times 10^{14}$ cm⁻², the resistance is well below the quantum resistance $h/e^2 = 25.8$ k Ω , and $dR_s/dT > 0$ persists down to the base temperature of 0.35 K. Note that the resistance peak when $n_s = 1.3 \times 10^{14}$ cm⁻² shifted upon the application of a magnetic field (see Fig. 5). An anomalous Hall effect was observed at this and nearby charge transfers. The inset shows the hysteretic behavior of the sharply rising curve with $n_s = 1.4 \times 10^{12}$ cm⁻². Similar behavior was observed at other carrier concentrations. The arrows in the inset indicate the temperature sweep direction.

of the voltage threshold for conductance as has been found in various oxide FETs [22]. However, the sharpness of the rise in $R_s(T)$, and the fact that it is hysteretic, as shown in the inset of Fig. 2, strongly suggest this behavior to be the signature of a first order phase transition in the layer that is electrostatically doped.

It is well known that chemically doped STO, exhibits superconductivity at relatively low bulk carrier densities $n_{\text{bulk}} \sim 10^{20} \text{ cm}^{-3}$ [1]. Recently EDLT configurations were used to induce superconductivity in an undoped insulating STO [10]. In the present work, we have produced a very similar result albeit with a different dielectric. The onset of a superconducting transition was observed at a temperature of about 0.4 K at $n_s = 3.9 \times 10^{14} \text{ cm}^{-2}$ (measured at 0.5 K). Superconductivity either disappears or is just shifted to lower temperatures, no longer accessible with our setup, as we increased the value of n_s . Data exhibiting the onset of superconductivity are shown in Fig. 3.

In Fig. 4. we plot $R_{xy} - R_0 B$ vs *B*, the Hall resistance R_{xy} vs *B* with the ordinary Hall effect (OHE) term, $R_0 B$ subtracted. This linear term was obtained from a fit to the high field limit with $R_0 = 1/(en_s)$. A deviation from the linearity of the Hall resistance vs magnetic field, known as anomalous Hall effect (AHE), is observed. Similar effects have been reported at the SrTiO₃/LaAlO₃ interface [23–25]. The AHE can result from a multiple band structure [24] and/or a magnetization induced by external field



FIG. 3 (color online). The onset of superconductivity at various values of n_s (in units of 10^{13} cm⁻², taken at 0.5 K). Note that at higher carrier densities the transition was not observed at temperatures down to 350 mK. In the inset, the *B* dependence of R_s at T = 400 mK for $n_s = 3.9 \times 10^{14}$ cm⁻² shows an increasing resistance until saturation above 0.3 T. This supports the observation of superconductivity.

[23,25]. The observation that the Hall resistance changes at low magnetic fields and saturates at some high field, favors the magnetization scenario. The AHE effect was not observed at temperatures of 90 K and above, as shown in the inset of Fig. 4.

The magnetic field dependence of R_s in the region where an AHE was observed was also investigated. Examples are



FIG. 4 (color online). Anomalous Hall effect. These data were obtained with $n_s = 1.3 \times 10^{14}$ cm⁻² (at 180 K) over a temperature range from 15 to 90 K. The AHE effect was not observed at temperatures of 90 K and above, as shown in the inset (The inset shows the original data before the OHE subtraction and they exhibit no signature of AHE.) A similar effect was observed at neighboring values of n_s .



FIG. 5 (color online). R_s vs T at various magnetic field up to 9 Tesla with $n_s = 13 \times 10^{13}$ cm⁻² with the latter obtained at 180 K. The lower-right inset shows $R_s(B)$ at $n_s = 2.0 \times 10^{13}$ cm⁻² and T = 95 K, which is the onset temperature for the sharp rise in $R_s(T)$ shown in Fig. 2. It exhibits no change with field.

shown in Fig. 5. The peak at $n_s = 1.3 \times 10^{14} \text{ cm}^{-2}$ shifted to higher temperatures upon the application of a magnetic field and the response to field was not hysteretic. Similar behavior was found at the somewhat lower carrier-density of $n_s = 8.2 \times 10^{13} \text{ cm}^{-2}$ (the upper-right inset of Fig. 5). This effect disappeared for carrier densities of $2.0 \times 10^{13} \text{ cm}^{-2}$ and lower (lower-right inset). We suspect this



FIG. 6 (color online). Phase diagram of STO: the plot of T vs n_s (taken at 180 K) shows the features found. The various dashed lines are simply guides to the eye. The dots represent temperatures and values of n_s at which R_s appeared to diverge. The vertically hatched regions correspond the approximate boundary where dR_s/dT changes sign, and the diamonds denote the onset of superconductivity, which does not change much, over a significant range of values of n_s . The other crosshatched region denotes the range of temperatures and carrier concentrations over which an AHE was found.

effect is associated with magnetic order. It should be noted that ferromagnetic order of the electron spins within the Ti-3*d* conduction band was predicted for both LaTiO₃/SrTiO₃ and LaAlO₃/SrTiO₃ interfaces [26,27] and evidence for this was presented by Brinkman *et al.* [28]. in the form of hysteretic magnetoresistance curves. In the present work there is no hysteresis. Consequently it is not certain that ferromagnetism is responsible for the observed phenomena.

Lastly, we have drawn a tentative phase diagram in the space of T and n_s , summarizing our observations (Fig. 6). Because of the limited temperature range of the PPMS, it is not certain that there exists a domelike feature for the variation of the superconducting transition temperature with n_s , analogous to the result found for chemically doped, bulk STO [1].

In summary, we have found a series of different behaviors of electrostatically doped STO with the doping carried out using an EDLT configuration. We have documented the systematic decrease of the temperature of carrier freezeout with increasing carrier concentration, with this apparent conductor-insulator transition disappearing when superconductivity turns on. The appearance of a peak in R(T), which is magnetic field dependent, in the vicinity of this crossover to superconductivity, along with an anomalous Hall effect suggests the possibility of a magnetic phase in the crossover regime. This is reminiscent of what is found near quantum critical points in strongly correlated electron systems [12]. Lower temperature measurements may elucidate the precise behavior. An open question is the actual depth of penetration of the induced charge layer. Recent theoretical work suggests that it may be localized within a very narrow layer on the order of 1 lattice constant rather than some greater distance [29]. If that is indeed the case then the properties revealed in this work need not be analogous to those found in bulk doping experiments.

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